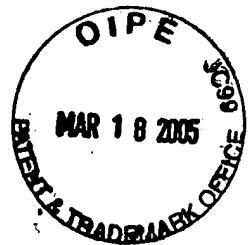


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Amendment D

UNITED STATES PATENT OFFICE

In re application of

R. David Rines

Serial No. 09/731,519

Art Unit: 2175

Filed: 12/06/2000

Examiner: Rimell, Samuel G.

For: METHOD OF AND SYSTEM FOR GENERATING DATA-BASE COMPILED
AND STORAGE, ACCESSING, COMPARING AND ANALYZING OF SCANNED
GENETIC SPOT PATTERN IMAGES AND THE LIKE

Commissioner for Patents
Mail Stop: Amendments
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Replying to the final Office action of January 1, 2005, please amend the
application as follows: